



IPW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of)	
Qinghong K. Gao et al.)	Group Art Unit: 1763
Application No.: 10/600,273)	Examiner: Not Yet Assigned
Filed: June 20, 2003)	Confirmation No.: 6096
For: MULTIPLE ZONE GAS DISTRIBUTION)	
APPARATUS FOR THERMAL)	
CONTROL OF SEMICONDUCTOR)	
WAFER)	

STATUS INQUIRY

Commissioner for Patents
P.O. Box 1450
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Sir:

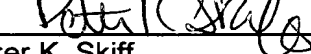
Please advise, in writing, as to the current status of the above-captioned application.

The above application was filed on June 20, 2003 and to date no Official Action has been received by the undersigned.

Respectfully submitted,

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Date: December 21, 2004

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